

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/437,135

Filed: November 10, 1999

For: SEMICONDUCTOR DEVICE AND METHOD
FOR FORMING THE SAME

)
) Group Art Unit: 2813
) Examiner: Erik J. Kielin
) Confirmation No. 7576
) Date: January 6, 2004

RESPONSE TO SPECIES ELECTION REQUIREMENT

Mail Stop - Non-Fee Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement/Election of Species
 December 10, 2003 applicants respond as follows.

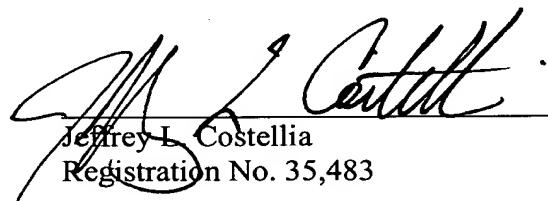
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REMARKS

In response to the Office Action of December 10, 2003, Applicants hereby elect Group II, forming TFTs using two laser annealing steps and readable on claims 1-14 and 29.

Consideration and allowance of the instant application are now respectfully requested.

Respectfully submitted,



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